

ABSTRACT

MANUFACTURING LINE FOR SEMICONDUCTOR DEVICE AND METHOD OF
MANUFACTURING SEMICONDUCTOR DEVICE

A manufacturing line (1) for a semiconductor device according to the invention is a manufacturing line for manufacturing a semiconductor device by circulating a workpiece (25) along a conveyance route (10) on which a plurality of treatment devices (20a to 20m) are arranged. The conveyance route (10) includes a first route (11) on which the treatment devices with a large number of times of treatment are arranged, and a second route (12) on which the treatment devices with a small number of times of treatment are arranged. Besides, the conveyance route (10) makes a changeover between the conveyance of the workpiece (25) that has moved along the first route (11) to the first route (11) in a continuous manner, and the conveyance of the workpiece (25) that has moved along the first route (11) to the second route (12).

FIG. 1